Serial No. 10/604,553 Art Unit 2871

## **LISTING OF THE CLAIMS:**

This listing of claims will replace all prior versions and listings of claims in the application:

Claim 1 through 12. (Cancelled).

Claim 13. (Currently amended) An apparatus for forming an alignment layer on a substrate of a liquid crystal display, comprising:

an irradiation source; and

a mask between the substrate and the irradiation source, said mask being defermed <u>curved</u> in a plane perpendicular to the substrate.

- Claim 14. (Previously presented) The apparatus according to claim 13, further comprising an external force exerted on said mask for deforming the mask.
- Claim 15. (Previously presented) The apparatus according to claim 13, wherein said mask is dynamically deformable.
- Claim 16. (Previously presented) The apparatus according to claim 13, wherein said mask comprises an edge that is deformed in a plane parallel to the substrate.
- Claim 17. (Previously presented) The apparatus according to claim 16, further comprising an external force exerted on said mask for deforming the mask.
- Claim 18. (Previously presented) The apparatus according to claim 16, wherein said mask is dynamically deformable.

Serial No. 10/604,553 Art Unit 2871

Claim 19. (New) An apparatus for forming an alignment layer on a substrate of a liquid crystal display, comprising:

an irradiation source; and

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a mask between the substrate and the irradiation source, said mask having an edge that is warped in a plane perpendicular to the substrate.

- Claim 20. (New) The apparatus according to claim 19, further comprising means for exerting an external force on said edge, said external force being sufficient to warp said edge.
- Claim 21. (New) The apparatus according to claim 19, wherein said edge is deformed in a plane parallel to the substrate.
- Claim 22. (New) An apparatus for forming an alignment layer on a substrate of a liquid crystal display, comprising:

an irradiation source;

a mask between the substrate and the irradiation source, said mask having an edge, wherein a distance between said edge and the substrate differs along at least a portion of said edge.

Claim 23. (New) The apparatus according to claim 22, wherein said edge is deformed in a plane parallel to the substrate.